

K827525 AUTOMATIC EXPOSURE CONTROL TYPE A3300Jun 18, 1982
28 days to decision

K827525 · Radiology

Source: <https://www.510kdatabase.net/k827525/>**SUBMISSION DETAILS**

Decision	Substantially Equivalent (Cleared)
Submission type	Traditional
Date received	May 21, 1982
Decision date	Jun 18, 1982
Days to decision	28 days
Third-party review	No

APPLICANT

Company	Advanced Instrument Development, Inc.
Location	Mchenry, IL, US
510(k) history	5 submissions · 5 cleared · 1979-1998

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